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NOBLE et al.

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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

TRANSLATION

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

- 1 PATENT ABSTRACTS OF JAPAN vol. 012, no. 177 (E-613), 05/1988 & JP 62 284600 (AGENCY OF IND SCIENCE & TECHNOL), 12/1987

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3 PEDERSEN M et al.: "A silicon condenser microphone with polyimide diaphragm and backplate" SENSORS AND ACTUATORS A, vol. 63, no. 2, 10/1997, pp. 97-104

4 SCHEEPER P R et al.: "FABRICATION OF SILICON CONDENSER MICROPHONES USING SINGLE WAFER TECHNOLOGY" JOURNAL OF MICROELECTROMECHANICAL SYSTEMS, vol. 1, no. 3, 09/1992, pp. 147-154

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6 MATTILA P et al.: "BANDWIDTH CONTROL OF AN ELECTROSTATIC ULTRASONIC TRANSDUCER" SENSORS AND ACTUATORS A, vol. A45, no. 3, 12/1994, pp. 203-208

***Examiner**

Date Considered

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